APR 2 3 2004

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 1256

Yoshihiro GUNJI et al.

Docket No. 2001-1075A

Serial No. 09/917,732

Group Art Unit 1763

Filed July 31, 2001

Examiner Sylvia MacArthur

SUBSTRATE HOLDING APPARATUS AND SUBSTRATE POLISHING APPARATUS

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## REQUEST TO TREAT AUTHORIZATION TO CHARGE ALL REQUIRED FEES AS AN EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants in the above-referenced U.S. patent application filed a response on April 22, 2004. This was in response to a first Office Action carrying a due date of March 22, 2004. Accordingly, a one month extension of time was required.

However, Applicants undersigned representative did not include a formal petition for the one month extension of time. The response filed April 22, 2004 did, however, include an authorization to charge any necessary fees for the paper. Accordingly, under the practice as set forth in 37 CFR 1.136(a)(3), second sentence, and as discussed in MPEP §710.02(e), the Office is respectfully